



Docket No.: 492322016900

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Akira SUZUKI et al.

Application No.: 10/784,888

Group Art Unit: 2812

Filed: February 24, 2004

Examiner: Not Yet Assigned

For: MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE

**CLAIM FOR PRIORITY AND SUBMISSION OF DOCUMENT**

Commissioner for Patents  
2011 South Clark Place  
Room 1B03, Crystal Plaza 2  
Arlington, Virginia, 22202

Sir:

Applicants hereby claim priority under 35 U.S.C. 119 based on the following prior foreign applications filed in the following foreign country on the date indicated:

<u>Country</u>	<u>Application No.</u>	<u>Date</u>
Japan	2003-046755	February 25, 2003
Japan	2004-026534	February 3, 2004

In support of this claim, certified copies of the original foreign applications are filed herewith.

Dated: July 16, 2004

Respectfully submitted,

By 

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